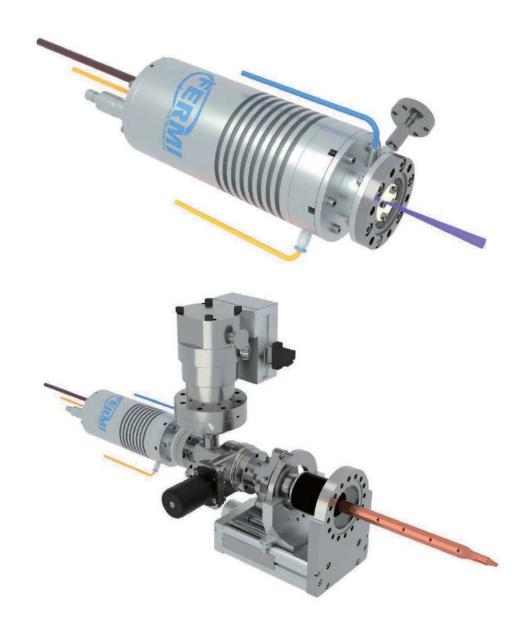
Section 7. VUV Sources



Section 7. VUV Source

- 7.1 Multi-Gas Ultra-High Flux VUV Source
- 7.2 Focused VUV Source



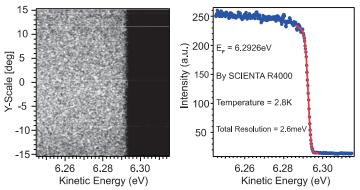
Section 7. VUV Sources



Description

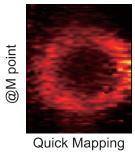
The new FERMI BL-1000 is an ultra-high efficiency UV source based on revolutionary local field plasma mechanism, integrated with latest solid RF source technology. Providing orders of magnitude higher efficiency than traditional plasma-base UV sources. BL-1000 is an electrode-free and ignite-free universal UV source, which can work with various gases and gas mixture. Providing broad applications, such as photoemission spectroscopy, mass spectroscopy, atomic absorption spectroscopy etc.

Gold Thin Film Test @ Kr(10.65eV)

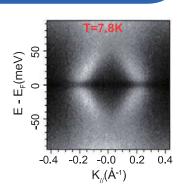


Courtesy of Prof. H. Ding's system in IOP, CAS

FeSe Thin Film Test @ He(21.2eV)



Quick Mapping (1 sweep)



Courtesy of Prof. D.L. FENG's system in Fudan University

Specification

- Multiple Working Gases
 He, Ne, Ar, Kr, Xe, ...
- Photon Energy 8.4eV - 40.8eV (30nm - 147nm)
- Photon Flux
 - Total VUV Flux: >1x10¹⁴ Photons/sec
 - > 10¹² Photons/sec @1mm² sample with appropriate monochromator and capillary
- Resolution
 - < 1meV@Xe(8.43eV)
- Power Supply
 Compact solid RF source driven by 24V/200 W power source
- UHV Compatible All Metal Seals



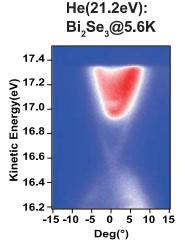
Section 7. VUV Sources



Description

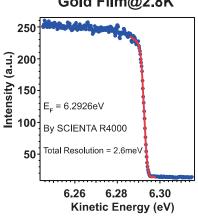
FIUV BL-1010s is a specially designed high brilliance multi-gas VUV source with three-stage differential chamber and UHV valve isolated focusing capillary. It can be operated with a wide variety of different gases (He, Ne, Ar, Kr, Xe ...) with small spot output and little working pressure increment.

Test Spetrum



Courtesy of Prof. Yihua Wang's system in Fudan University

Kr(10.65eV): Gold Film@2.8K



Courtesy of Prof. H. Ding's system in IOP, CAS

Specification

- Total VUV Flux: >3 x 10¹³ photons/sec
- Spot size: ~0.5mm
- Line Width: <1meV @Xe(8.43eV)</p>
- Three-Stage differential pumping
- High efficiency focus and transfer capillary
- Full Set RF Generator, cable and power supply
- Compulsry air cooling and water cooling
- All-metal-sealed source with UHV compatible

Option: Supporting Frame

- Retractable mechanism
- 75mm Linear Translator
- Alignment Mechanism
- Tilt mechanism: ±3°

